

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yukio Kuramasu

Application No.: 10/560,270

Filed: January 5, 2006

For: **IMPURITY MEASURING METHOD  
AND DEVICE**

Examiner: Michael J. Vanchy Jr.,

Art Group: 2624

Confirmation No.: 3356

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Sir:

In response to the Office Action mailed June 24, 2008 regarding the above-referenced application, Applicants respectfully request entry of the amendments set forth below in consideration of the remarks that follow.